# Beam Transfer Lines

- Distinctions between transfer lines and circular machines
- Linking machines together
- Blow-up from steering errors
- Correction of injection oscillations
- Blow-up from optics mismatch
- Optics measurement
- Blow-up from thin screens

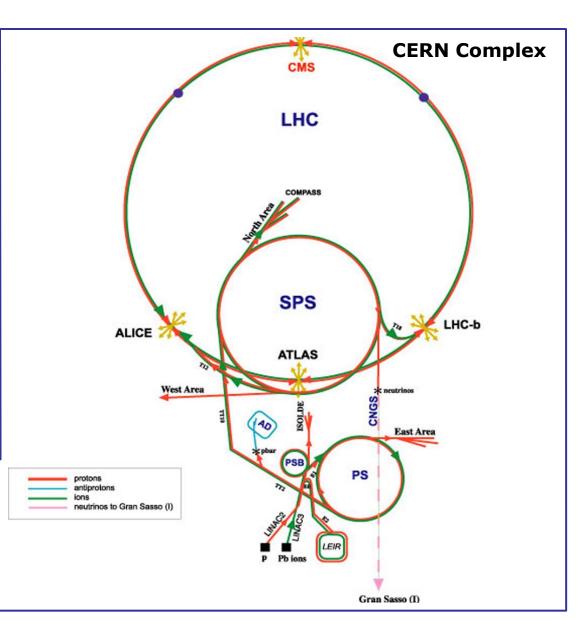
#### Verena Kain CERN (based on lecture by B. Goddard and M. Meddahi)

#### Injection, extraction and transfer

- An accelerator has limited dynamic range
- Chain of stages needed to reach high energy
- Periodic re-filling of storage rings, like LHC
- External experiments, like CNGS

Transfer lines transport the beam between accelerators, and onto targets, dumps, instruments etc.

LHC:	Large Hadron Collider
SPS:	Super Proton Synchrotron
AD:	Antiproton Decelerator
ISOLDE:	Isotope Separator Online Device
PSB:	Proton Synchrotron Booster
PS:	Proton Synchrotron
LINAC:	LINear Accelerator
LEIR:	Low Energy Ring
CNGS:	<b>CERN Neutrino to Gran Sasso</b>

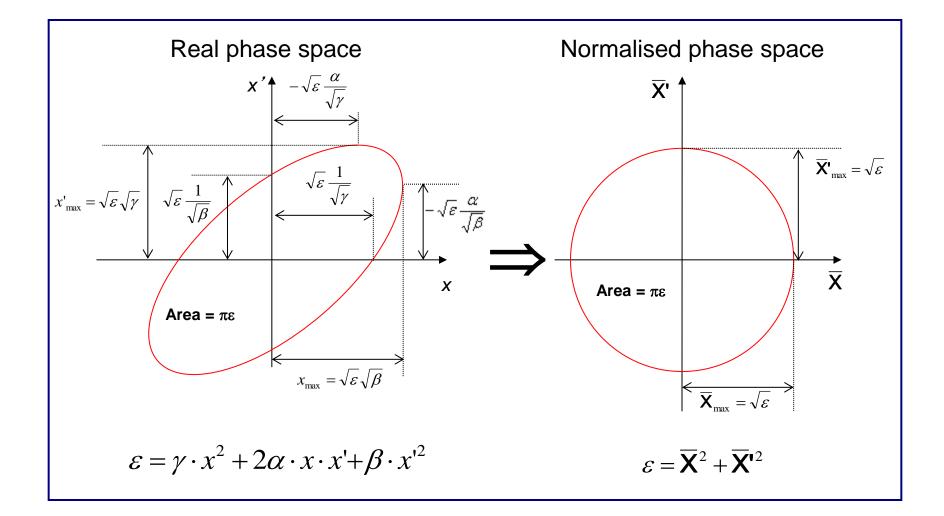


#### Normalised phase space

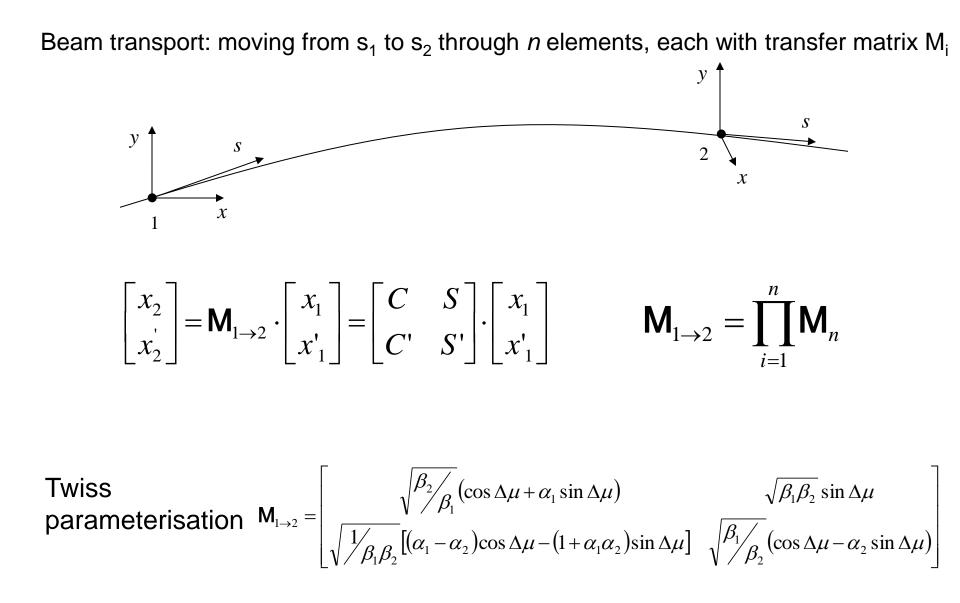
• Transform real transverse coordinates *x*, *x* ' by

$$\begin{bmatrix} \overline{\mathbf{X}} \\ \overline{\mathbf{X}'} \end{bmatrix} = \mathbf{N} \cdot \begin{bmatrix} x \\ x' \end{bmatrix} = \sqrt{\frac{1}{\beta_s}} \cdot \begin{bmatrix} 1 & 0 \\ \alpha_s & \beta_s \end{bmatrix} \cdot \begin{bmatrix} x \\ x' \end{bmatrix}$$
$$\overline{\mathbf{X}} = \sqrt{\frac{1}{\beta_s}} \cdot x$$
$$\overline{\mathbf{X}'} = \sqrt{\frac{1}{\beta_s}} \cdot \alpha_s x + \sqrt{\beta_s} x'$$

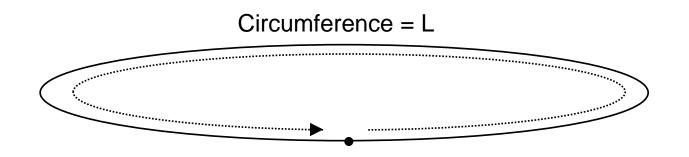
#### Normalised phase space



#### General transport



#### **Circular Machine**

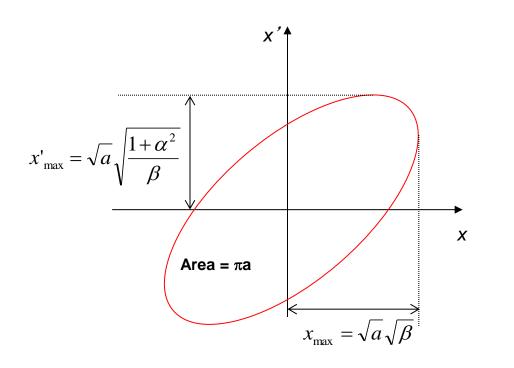


One turn 
$$\mathsf{M}_{1\to 2} = \mathsf{M}_{0\to L} = \begin{bmatrix} \cos 2\pi Q + \alpha \sin 2\pi Q & \beta \sin 2\pi Q \\ -\frac{1}{\beta} \left(1 + \alpha^2\right) \sin 2\pi Q & \cos 2\pi Q - \alpha \sin 2\pi Q \end{bmatrix}$$

- The solution is *periodic*
- Periodicity condition for one turn (closed ring) imposes  $\alpha_1 = \alpha_2$ ,  $\beta_1 = \beta_2$ ,  $D_1 = D_2$
- This condition *uniquely* determines  $\alpha(s)$ ,  $\beta(s)$ ,  $\mu(s)$ , D(s) around the whole ring

# **Circular Machine**

- Periodicity of the structure leads to regular motion
  - Map single particle coordinates on each turn at any location
  - Describes an ellipse in phase space, defined by one set of  $\alpha$  and  $\beta$  values  $\Rightarrow$  Matched Ellipse (for this location)

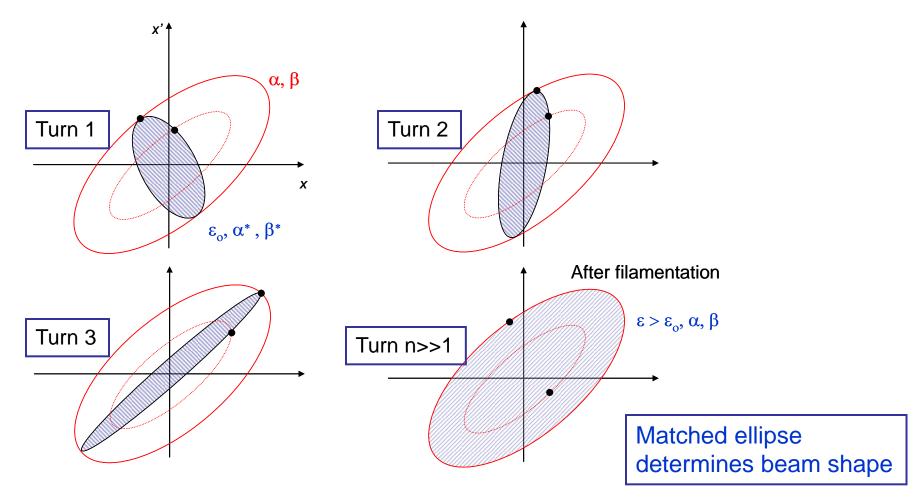


$$a = \gamma \cdot x^2 + 2\alpha \cdot x \cdot x' + \beta \cdot x'^2$$

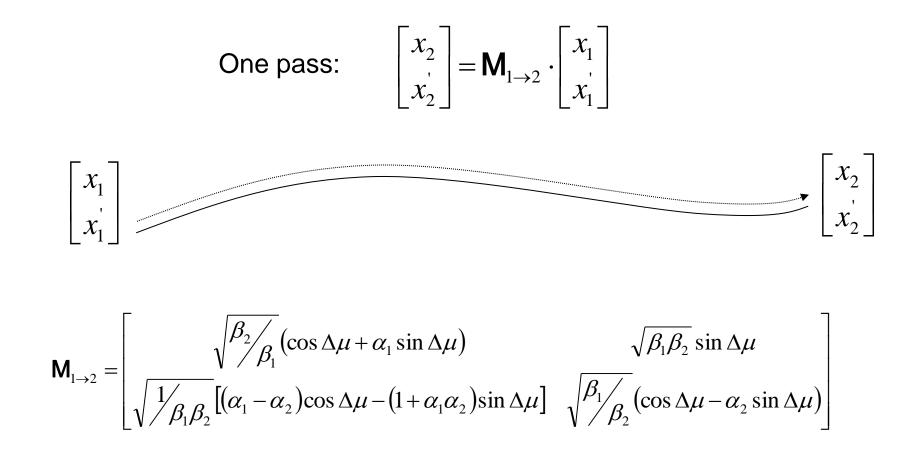
$$\gamma = \frac{1 + \alpha^2}{\beta}$$

# **Circular Machine**

For a location with matched ellipse (α, β), an injected beam of emittance ε, characterised by a different ellipse (α<sup>\*</sup>, β<sup>\*</sup>) generates (via filamentation) a large ellipse with the original α, β, but larger ε



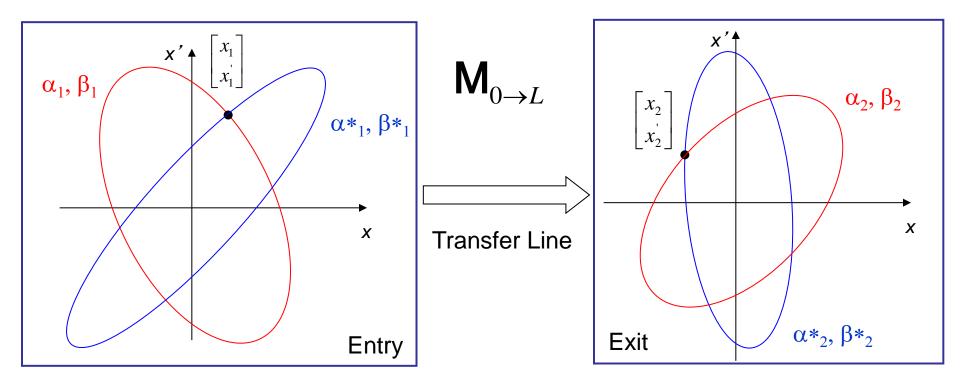
# **Transfer line**



- No periodic condition exists
- The Twiss parameters are simply propagated from beginning to end of line
- At any point in line,  $\alpha(s) \beta(s)$  are functions of  $\alpha_1 \beta_1$

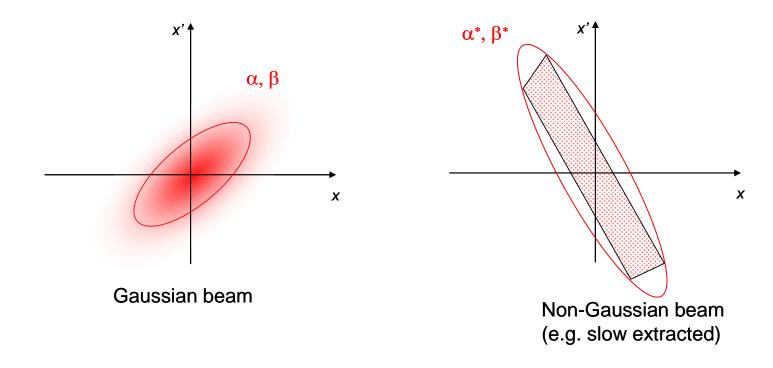
# **Transfer line**

- On a single pass...
  - Map single particle coordinates at entrance and exit.
  - <u>Infinite number of equally valid possible starting ellipses for single particle</u> .....transported to infinite number of final ellipses...



# **Transfer Line**

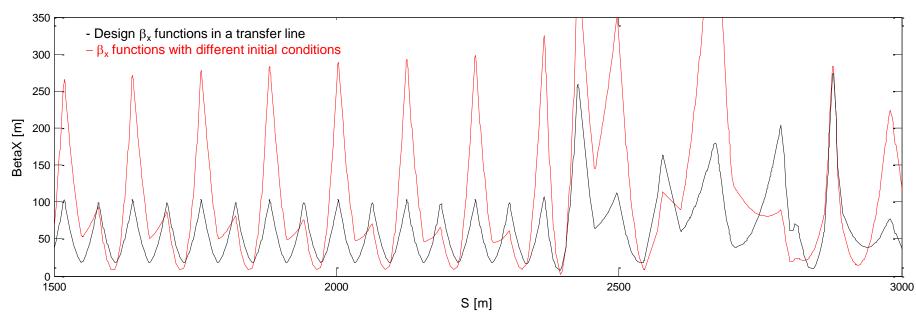
• Initial  $\alpha$ ,  $\beta$  defined for transfer line by beam shape at entrance



- Propagation of this beam ellipse depends on line elements
- <u>A transfer line optics is different for different input beams</u>

# **Transfer Line**

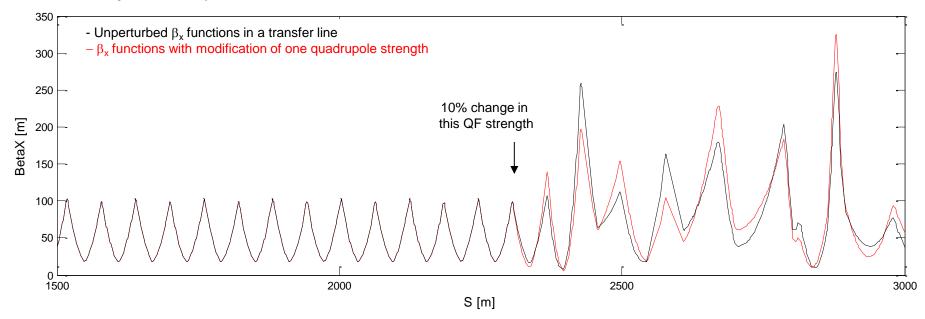
• The optics functions in the line depend on the initial values



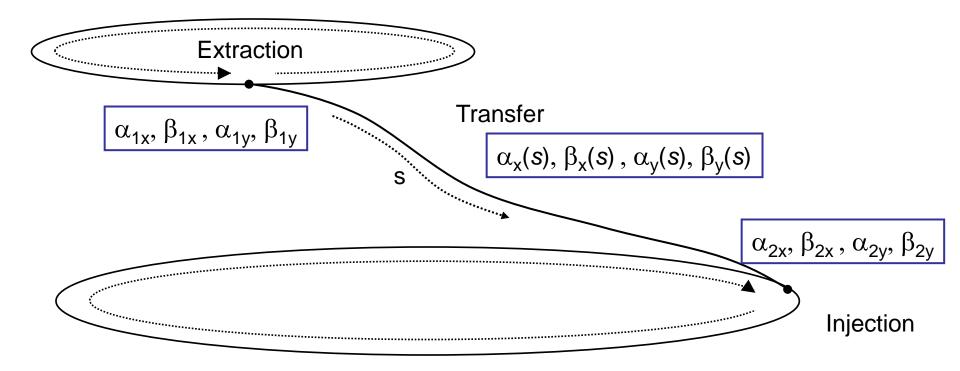
- Same considerations are true for Dispersion function:
  - Dispersion in ring defined by periodic solution  $\rightarrow$  ring elements
  - Dispersion in line defined by initial D and D' and line elements

# **Transfer Line**

 Another difference....unlike a circular ring, <u>a change of an element</u> in a line affects only the downstream Twiss values (including dispersion)



- Beams have to be transported from extraction of one machine to injection of next machine
  - Trajectories must be matched, ideally in all 6 geometric degrees of freedom (x,y,z,\theta,\phi,\psi)
- Other important constraints can include
  - Minimum bend radius, maximum quadrupole gradient, magnet aperture, cost, geology



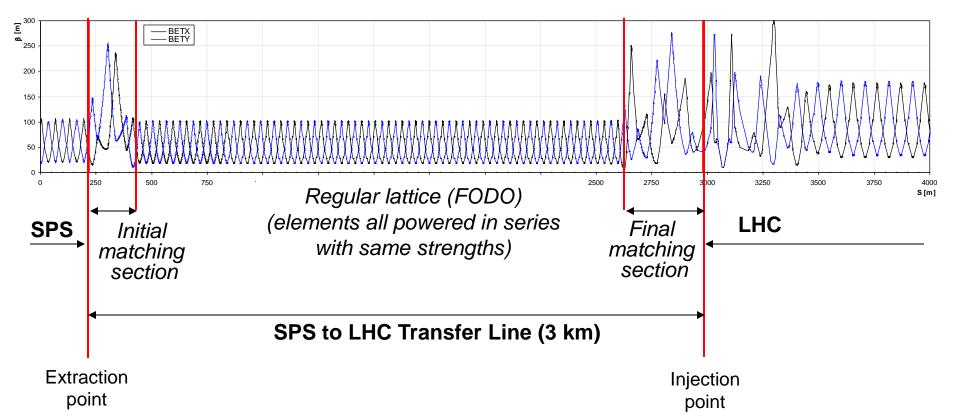
The Twiss parameters can be propagated when the transfer matrix  ${\bf M}$  is known

$$\begin{bmatrix} x_2 \\ x_2 \end{bmatrix} = \mathbf{M}_{1 \to 2} \cdot \begin{bmatrix} x_1 \\ x_1 \end{bmatrix} = \begin{bmatrix} C & S \\ C' & S' \end{bmatrix} \cdot \begin{bmatrix} x_1 \\ x_1 \end{bmatrix}$$

$$\begin{bmatrix} \beta_2 \\ \alpha_2 \\ \gamma_2 \end{bmatrix} = \begin{bmatrix} C^2 & -2CS & S^2 \\ -CC' & CS' + SC' & -SS' \\ C'^2 & -2C'S' & S'^2 \end{bmatrix} \cdot \begin{bmatrix} \beta_1 \\ \alpha_1 \\ \gamma_1 \end{bmatrix}$$

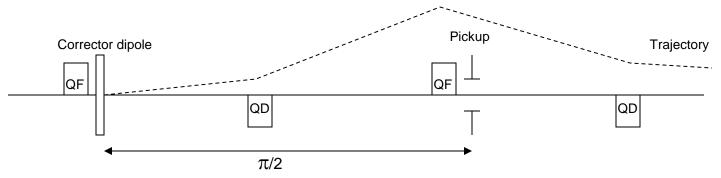
- Linking the optics is a complicated process
  - Parameters at start of line have to be propagated to matched parameters at the end of the line
  - Need to "match" 8 variables ( $\alpha_x \beta_x D_x D'_x$  and  $\alpha_y \beta_y D_y D'_y$ )
  - Maximum  $\beta$  and D values are imposed by magnet apertures
  - Other constraints can exist
    - phase conditions for collimators,
    - insertions for special equipment like stripping foils
  - Need to use a number of independently powered ("matching") quadrupoles
  - Matching with computer codes and relying on mixture of theory, experience, intuition, trial and error, …

- For long transfer lines we can simplify the problem by designing the line in separate sections
  - Regular central section e.g. FODO or doublet, with quads at regular spacing, (+ bending dipoles), with magnets powered in series
  - Initial and final matching sections independently powered quadrupoles, with sometimes irregular spacing.



# **Trajectory correction**

- Magnet misalignments, field and powering errors cause the trajectory to deviate from the design
- Use small independently powered dipole magnets (correctors) to steer the beam
- Measure the response using monitors (pick-ups) downstream of the corrector ( $\pi/2$ ,  $3\pi/2$ , ...)

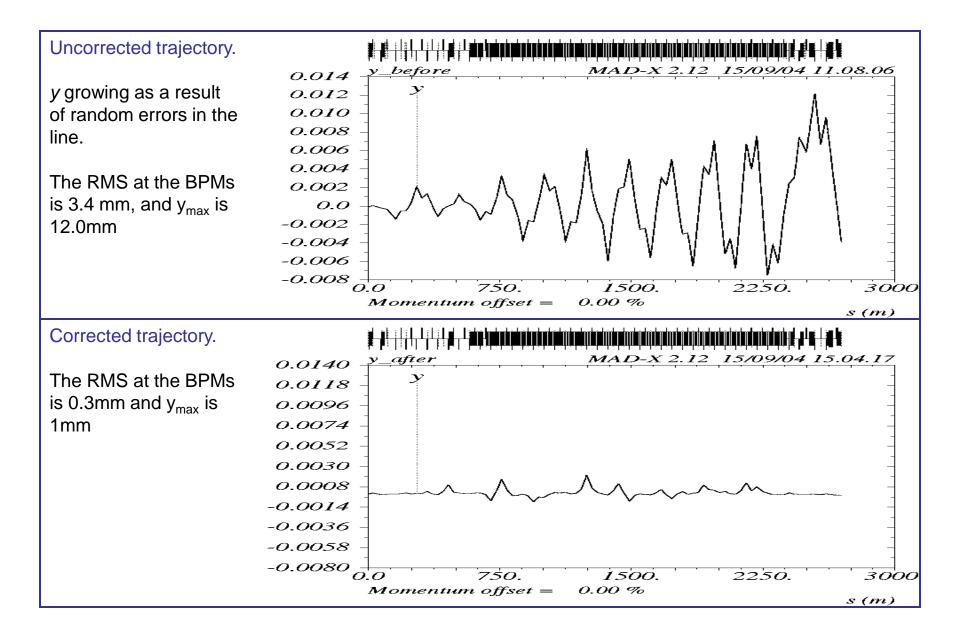


- Horizontal and vertical elements are separated
- H-correctors and pick-ups located at F-quadrupoles (large β<sub>x</sub>)
- V-correctors and pick-ups located at D-quadrupoles (large  $\beta_v$ )

# **Trajectory correction**

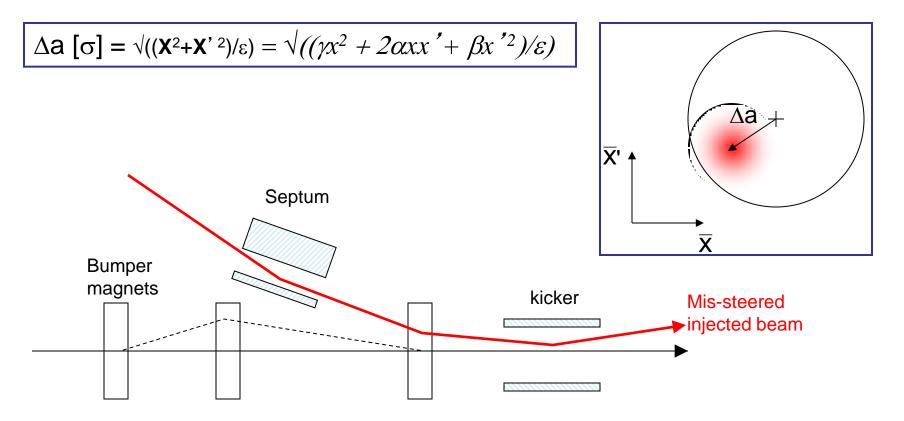
- Global correction can be used which attempts to minimise the RMS offsets at the BPMs, using all or some of the available corrector magnets.
- Steering in matching sections, extraction and injection region requires particular care
  - D and  $\beta$  functions can be large  $\rightarrow$  bigger beam size
  - Often very limited in aperture
  - Injection offsets can be detrimental for performance

### **Trajectory correction**



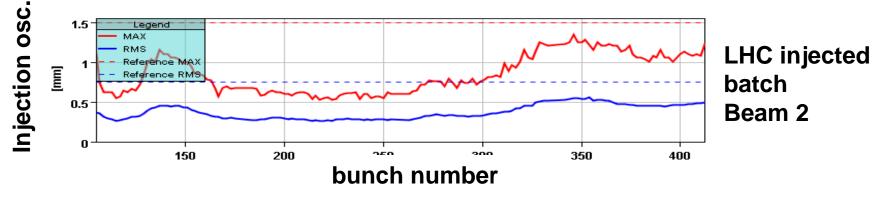
#### Steering (dipole) errors

- Precise delivery of the beam is important.
  - To avoid injection oscillations and emittance growth in rings
  - For stability on secondary particle production targets
- Convenient to express injection error in  $\sigma$  (includes x and x' errors)



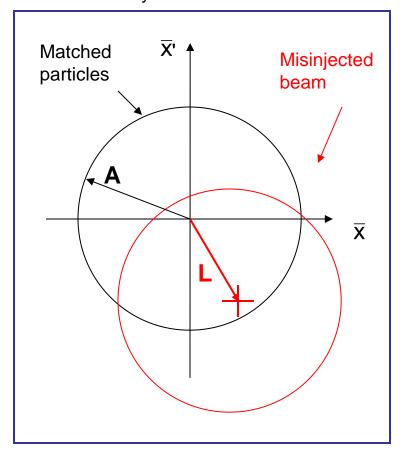
### Steering (dipole) errors

- Static effects (e.g. from errors in alignment, field, calibration, ...) are dealt with by trajectory correction (steering).
- But there are also dynamic effects, from:
  - Power supply ripples
  - Temperature variations
  - Non-trapezoidal kicker waveforms
- These dynamic effects produce a variable injection offset which can vary from batch to batch, or even within a batch.



 An injection damper system is used to minimize effect on emittance

- Consider a collection of particles with max. amplitudes A
- The beam can be injected with a error in angle and position.
- For an injection error  $\Delta a_y$  (in units of sigma =  $\sqrt{\beta \epsilon}$ ) the mis-injected beam is offset in normalised phase space by L =  $\Delta a_y \sqrt{\epsilon}$



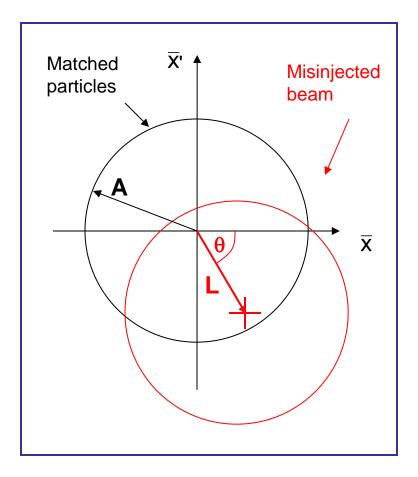
• The new particle coordinates in normalised phase space are

$$\overline{\mathbf{X}}_{new} = \overline{\mathbf{X}}_{0} + \mathbf{L}cos\theta$$

$$\overline{\mathbf{X}}'_{new} = \overline{\mathbf{X}}'_{0} + \mathbf{L}sin\theta$$

 For a general particle distribution, where A denotes amplitude in normalised phase space

$$A^{2} = \overline{X}^{2} + \overline{X}^{2}$$
$$\varepsilon = \langle A^{2} \rangle / 2$$



• So if we plug in the new coordinates....

$$\boldsymbol{A}_{new}^{2} = \boldsymbol{\bar{X}}_{new}^{2} + \boldsymbol{\bar{X}}_{new}^{'2} = \left(\boldsymbol{\bar{X}}_{\boldsymbol{\theta}} + \boldsymbol{Lcos}\boldsymbol{\theta}\right)^{2} + \left(\boldsymbol{\bar{X}}_{\boldsymbol{\theta}}^{'} + \boldsymbol{Lsin}\boldsymbol{\theta}\right)^{2}$$

$$= \bar{\boldsymbol{X}}_{\boldsymbol{\theta}}^{2} + \bar{\boldsymbol{X}}_{\boldsymbol{\theta}}^{\prime 2} + 2\boldsymbol{L} (\bar{\boldsymbol{X}}_{\boldsymbol{\theta}} cos\theta + \bar{\boldsymbol{X}}_{\boldsymbol{\theta}}^{\prime} sin\theta) + \boldsymbol{L}^{2}$$

$$\left\langle \boldsymbol{A}_{new}^{2} \right\rangle = \left\langle \boldsymbol{\bar{X}}_{\boldsymbol{\theta}}^{2} \right\rangle + \left\langle \boldsymbol{\bar{X}}_{\boldsymbol{\theta}}^{\prime 2} \right\rangle + \left\langle 2\boldsymbol{L} \left( \boldsymbol{\bar{X}}_{\boldsymbol{\theta}} \boldsymbol{cos\theta} + \boldsymbol{\bar{X}}_{\boldsymbol{\theta}}^{\prime} \boldsymbol{sin\theta} \right) \right\rangle + \left\langle \boldsymbol{L}^{2} \right\rangle$$

$$= 2\varepsilon_{0} + 2\boldsymbol{L} \left( \left\langle \boldsymbol{cos\theta} \boldsymbol{\bar{X}}_{\boldsymbol{\theta}} \right\rangle^{2} + \left\langle \boldsymbol{sin\theta} \boldsymbol{\bar{X}}_{\boldsymbol{\theta}}^{\prime} \right\rangle \right) + \boldsymbol{L}^{2}$$

$$= 2\varepsilon_0 + L^2$$

• Giving for the emittance increase

$$\varepsilon_{new} = \langle \mathbf{A}_{new}^{2} \rangle / 2 = \varepsilon_0 + \mathbf{L}^2 / 2$$

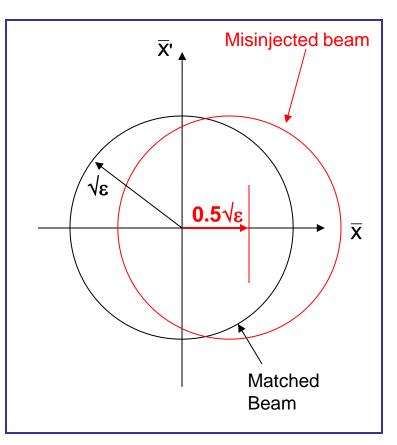
$$=\varepsilon_0 \left(1 + \Delta \mathbf{a^2} / 2\right)$$

A numerical example....

Consider an offset  $\Delta a$  of 0.5 sigma for injected beam

$$\varepsilon_{new} = \varepsilon_0 \left( 1 + \Delta a^2 / 2 \right)$$
$$= 1.125\varepsilon_0$$

For nominal LHC beam:  $\epsilon_{norm} = 3.5 \ \mu m$ allowed growth through LHC cycle ~ 10 %

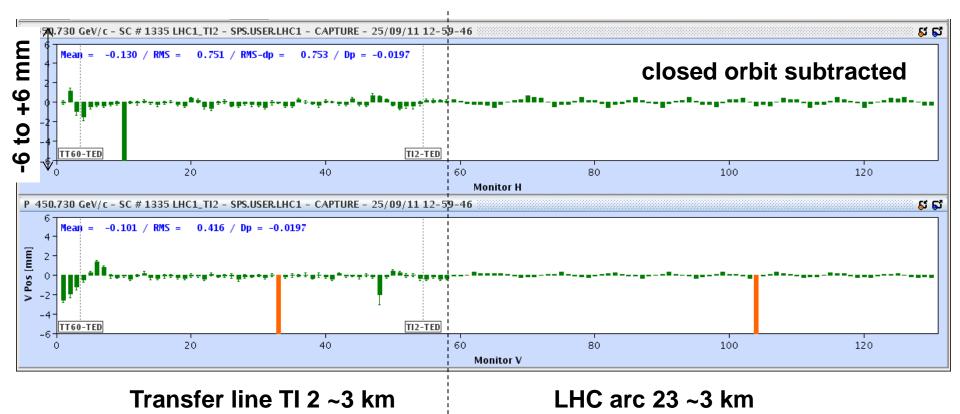


# Injection oscillation correction

- x, x' and y, y' at injection point need to be corrected.
- Minimum diagnostics: 2 pickups per plane, 90° phase advance apart
- Pickups need to be triggered to measure on the first turn
- Correctors in the transfer lines are used to minimize offset at these pickups.
- Best strategy:
  - Acquire many BPMs in circular machine (e.g. one octant/sextant of machine)
  - Combine acquisition of transfer line and of BPMs in circular machine
    - Transfer line: difference trajectory to reference
    - Circular machine: remove closed orbit from first turn trajectory → pure injection oscillation
  - Correct combined trajectory with correctors in transfer line with typical correction algorithms. Use correctors of the line only.

# Example: LHC injection of beam 1

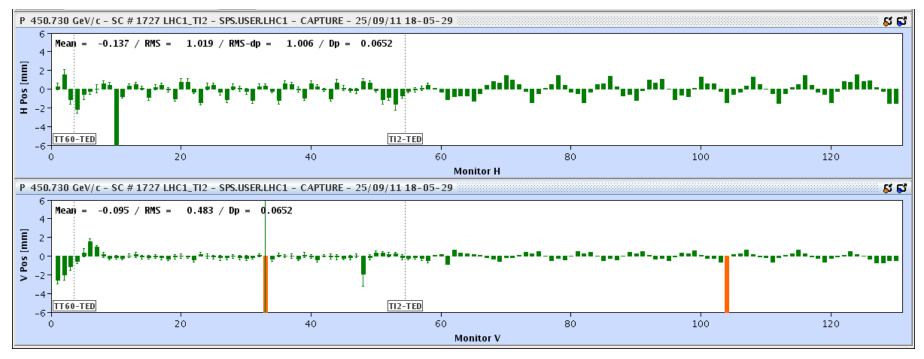
Display from the LHC control room to correct injection oscillations



Injection point in LHC IR2

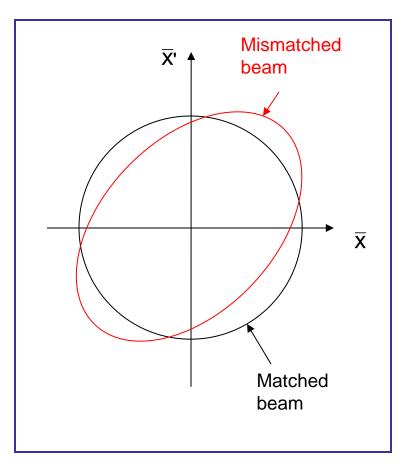
# Example: LHC injection of beam 1

- Oscillation down the line has developed in horizontal plane
- Injection oscillation amplitude > 1.5 mm
- Good working range of LHC transverse damper +/- 2 mm



- Aperture margin for injection oscillation is 2 mm
- $\odot$   $\rightarrow$  correct trajectory in line before continue LHC filling

- Optical errors occur in transfer line and ring, such that the beam can be injected with a mismatch.
- Filamentation will produce an emittance increase.
- In normalised phase space, consider the matched beam as a circle, and the mismatched beam as an ellipse.



General betatron motion

$$x_2 = \sqrt{a_2 b_2} \sin(j + j_o), \quad x'_2 = \sqrt{a_2 / b_2} \left[\cos(j + j_o) - \partial_2 \sin(j + j_o)\right]$$

applying the normalising transformation for the matched beam

$$\begin{bmatrix} \overline{\mathbf{X}}_{2} \\ \overline{\mathbf{X}'}_{2} \end{bmatrix} = \sqrt{\frac{1}{\beta_{1}}} \cdot \begin{bmatrix} 1 & 0 \\ \alpha_{1} & \beta_{1} \end{bmatrix} \cdot \begin{bmatrix} x_{2} \\ x'_{2} \end{bmatrix}$$

an ellipse is obtained in normalised phase space

$$A^{2} = \overline{\mathsf{X}}_{2}^{2} \left[ \frac{\beta_{1}}{\beta_{2}} + \frac{\beta_{2}}{\beta_{1}} \left( \alpha_{1} - \alpha_{2} \frac{\beta_{1}}{\beta_{2}} \right)^{2} \right] + \overline{\mathsf{X}}_{2}^{2} \frac{\beta_{2}}{\beta_{1}} - 2\overline{\mathsf{X}}_{2} \overline{\mathsf{X}}_{2}^{\prime} \left[ \frac{\beta_{2}}{\beta_{1}} \left( \alpha_{1} - \alpha_{2} \frac{\beta_{1}}{\beta_{2}} \right) \right]$$

characterised by  $\gamma_{new}$ ,  $\beta_{new}$  and  $\alpha_{new}$ , where

$$\alpha_{new} = \frac{-\beta_2}{\beta_1} \left( \alpha_1 - \alpha_2 \frac{\beta_1}{\beta_2} \right), \qquad \beta_{new} = \frac{\beta_2}{\beta_1}, \quad \gamma_{new} = \frac{\beta_1}{\beta_2} + \frac{\beta_2}{\beta_1} \left( \alpha_1 - \alpha_2 \frac{\beta_1}{\beta_2} \right)^2$$

From the general ellipse properties

$$a = \frac{A}{\sqrt{2}} \left( \sqrt{H+1} + \sqrt{H-1} \right), \quad b = \frac{A}{\sqrt{2}} \left( \sqrt{H+1} - \sqrt{H-1} \right)$$
where
$$H = \frac{1}{2} \left( \gamma_{new} + \beta_{new} \right)$$

$$= \frac{1}{2} \left( \frac{\beta_1}{\beta_2} + \frac{\beta_2}{\beta_1} \left( \alpha_1 - \alpha_2 \frac{\beta_1}{\beta_2} \right)^2 + \frac{\beta_2}{\beta_1} \right)$$
giving
$$\lambda = \frac{1}{\sqrt{2}} \left( \sqrt{H+1} + \sqrt{H-1} \right), \quad \frac{1}{\lambda} = \frac{1}{\sqrt{2}} \left( \sqrt{H+1} - \sqrt{H-1} \right)$$

$$\overline{X}_{new} = \lambda \cdot A \sin(\phi + \phi_1), \qquad \overline{X}_{new} = \frac{1}{\lambda} A \cos(\phi + \phi_1)$$

$$generally$$

$$a = A/\lambda$$

$$b = A \cdot \lambda$$

We can evaluate the square of the distance of a particle from the origin as

$$\mathsf{A}_{new}^2 = \overline{\mathsf{X}}_{new}^2 + \overline{\mathsf{X}}_{new}^2 = \lambda^2 \cdot \mathsf{A}_0^2 \sin^2(\phi + \phi_1) + \frac{1}{\lambda^2} \mathsf{A}_0^2 \cos^2(\phi + \phi_1)$$

The new emittance is the average over all phases

$$\varepsilon_{new} = \frac{1}{2} \left\langle \mathsf{A}_{new}^2 \right\rangle = \frac{1}{2} \left( \lambda^2 \left\langle \mathsf{A}_0^2 \sin^2(\phi + \phi_1) \right\rangle + \frac{1}{\lambda^2} \left\langle \mathsf{A}_0^2 \cos^2(\phi + \phi_1) \right\rangle \right)$$
$$= \frac{1}{2} \left\langle \mathsf{A}_0^2 \right\rangle \left( \lambda^2 \left\langle \sin^2(\phi + \phi_1) \right\rangle + \frac{1}{\lambda^2} \left\langle \cos^2(\phi + \phi_1) \right\rangle \right)$$
$$= \frac{1}{2} \varepsilon_0 \left( \lambda^2 + \frac{1}{\lambda^2} \right)$$

If we're feeling diligent, we can substitute back for  $\lambda$  to give

$$\varepsilon_{new} = \frac{1}{2}\varepsilon_0 \left(\lambda^2 + \frac{1}{\lambda^2}\right) = H\varepsilon_0 = \frac{1}{2}\varepsilon_0 \left(\frac{\beta_1}{\beta_2} + \frac{\beta_2}{\beta_1}\left(\alpha_1 - \alpha_2\frac{\beta_1}{\beta_2}\right)^2 + \frac{\beta_2}{\beta_1}\right)$$

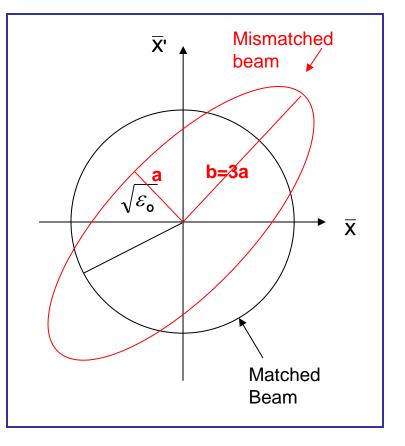
where subscript 1 refers to matched ellipse, 2 to mismatched ellipse.

A numerical example....consider b = 3a for the mismatched ellipse

$$\lambda = \sqrt{b/a} = \sqrt{3}$$

Then

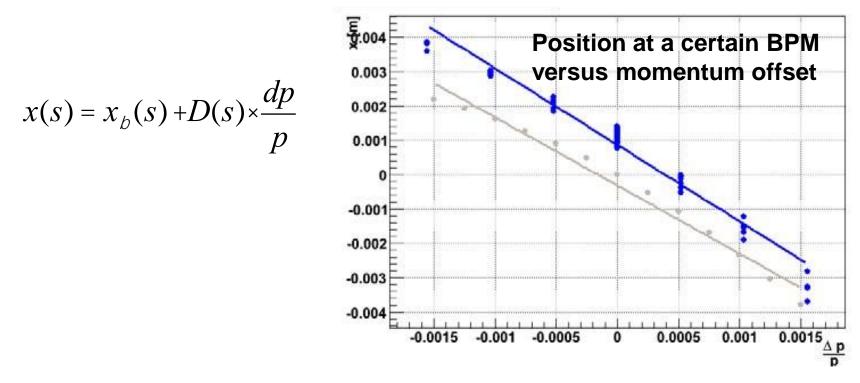
$$\varepsilon_{new} = \frac{1}{2} \varepsilon_0 \left( \lambda^2 + 1/\lambda^2 \right)$$
$$= 1.67 \varepsilon_0$$



# OPTICS AND EMITTANCE MEASUREMENT IN TRANSFER LINES

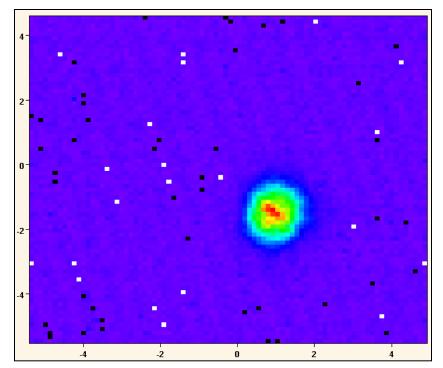
### **Dispersion measurement**

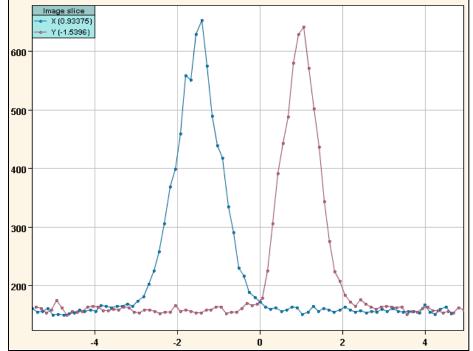
- Introduce ~ few permille momentum offset at extraction into transfer line
- Measure position at different monitors for different momentum offset
  - Linear fit of position versus dp/p at each BPM/screens.
  - $\Box$   $\Box$  Dispersion at the BPMs/screens



# Optics measurement with screens

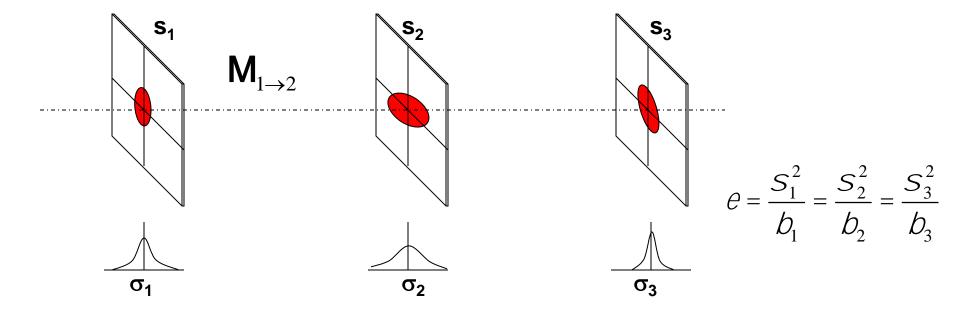
- A profile monitor is needed to measure the beam size
  - e.g. beam screen (luminescent) provides 2D density profile of the beam
- Profile fit gives transverse beam sizes  $\sigma$ .
- In a ring,  $\beta$  is 'known' so  $\epsilon$  can be calculated from a single screen





## **Optics Measurement with 3 Screens**

- Assume 3 screens in a dispersion free region
- Measurements of  $\sigma_1, \sigma_2, \sigma_3$ , plus the two transfer matrices  $M_{12}$  and  $M_{13}$  allows determination of  $\epsilon, \alpha$  and  $\beta$



### **Optics Measurement with 3 Screens**

• Remember:

$$\begin{bmatrix} x_{2} \\ x_{2} \end{bmatrix} = \mathbf{M}_{1 \to 2} \cdot \begin{bmatrix} x_{1} \\ x_{1}' \end{bmatrix} = \begin{bmatrix} C & S \\ C' & S' \end{bmatrix} \cdot \begin{bmatrix} x_{1} \\ x_{1}' \end{bmatrix}$$

$$\stackrel{\acute{e}}{\stackrel{0}{e}} b_{2} \stackrel{\acute{u}}{\stackrel{\acute{e}}{\underline{\theta}}} C_{2}^{2} - 2C_{2}S_{2} \qquad S_{2}^{2} \stackrel{\acute{u}}{\stackrel{\acute{e}}{\underline{\theta}}} b_{1} \stackrel{\acute{u}}{\underline{\theta}}$$

$$\stackrel{\acute{e}}{\stackrel{0}{e}} a_{2} \stackrel{\acute{u}}{\underline{\theta}} \stackrel{\acute{e}}{\underline{\theta}} - C_{2}C_{2} \quad C_{1}S_{1} + S_{1}C_{1} \quad -S_{2}S_{2} \quad \acute{u} \times \hat{e} \quad a_{1} \quad \acute{u}$$

$$\stackrel{\acute{e}}{\stackrel{\acute{e}}{\underline{\theta}}} g_{2} \stackrel{\acute{u}}{\underline{\theta}} \stackrel{\acute{e}}{\underline{\theta}} C_{2}^{2} - 2C_{2} \quad S_{2} \quad S_{2}^{2} \quad \acute{u} \times \hat{e} \quad a_{1} \quad \acute{u}$$

$$D_{2} = C_{2} \times D_{1} - 2C_{2}S_{2} \times \partial_{1} + S_{2} \times \mathcal{G}_{1}$$
$$D_{3} = C_{3}^{2} \times D_{1} - 2C_{3}S_{3} \times \partial_{1} + S_{3}^{2} \times \mathcal{G}_{1}$$
 × **E**

$$S_{2}^{2} = C_{2}^{2} \times b_{1}e - 2C_{2}S_{2} \times a_{1}e + S_{2}^{2} \times g_{1}e$$
  
$$S_{3}^{2} = C_{3}^{2} \times b_{1}e - 2C_{3}S_{3} \times a_{1}e + S_{3}^{2} \times g_{1}e$$

Square of beam sizes as function of optical functions at first screen

## **Optics Measurement with 3 Screens**

• Define matrix N where  $\Sigma = N\Pi$ 

- Measure beam sizes and want to calculate  $\beta_1$ ,  $\alpha_1$ ,  $\epsilon$
- Solution to our problem  $\Sigma' = \mathbf{N}^{-1}\Sigma$ 
  - with  $\beta_1\gamma_1 \alpha_1^2 = 1$  get 3 equations for  $\beta_1$ ,  $\alpha_1$  and  $\epsilon$  the optical functions at the first screen

$$b_{1} = A / \sqrt{AC - B^{2}} \qquad A = S_{1}^{c}$$
  

$$a_{1} = B / \sqrt{AC - B^{2}} \qquad \text{with} \qquad B = S_{2}^{c}$$
  

$$e = \sqrt{AC - B^{2}} \qquad C = S_{3}^{c}$$

# ...and if there is dispersion at the screens

- Dispersion and momentum spread need to be measured independently at the different screens
- Trajectory transforms with  $T_i$  transport matrix for  $\delta \neq 0$ 
  - $\Box$   $\xi_i$  is the contribution to the dispersion between the first and the i<sup>th</sup> screen

- Define 6 dimensional  $\Sigma$  and  $\Pi$  and respective N and then same procedure as before

$$S = \begin{pmatrix} \hat{k} & S_{1}^{2} & 0 & \\ \hat{\zeta} & S_{2}^{2} & \hat{\cdot} & \\ \hat{\zeta} & S_{2}^{2} & \hat{\cdot} & \\ \hat{\zeta} & S_{3}^{2} & \hat{\cdot} & \\ \hat{\zeta} & D_{1}d^{2} & \hat{\zeta} & \\ \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \\ \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \\ \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \\ \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \\ \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \\ \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \\ \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \\ \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \\ \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \\ \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \\ \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \\ \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \\ \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \\ \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \\ \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \\ \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \\ \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \\ \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \hat{\zeta} & \\ \hat{\zeta} & \hat{\zeta}$$

## 6 screens with dispersion

 Can measure β, α, ε, D, D' and δ with 6 screens without any other measurements.

$$\Sigma = \begin{pmatrix} \sigma_1^2 \\ \sigma_2^2 \\ \sigma_3^2 \\ \sigma_4^2 \\ \sigma_5^2 \\ \sigma_6^2 \end{pmatrix}, \Pi = \begin{pmatrix} \beta_1 \varepsilon + D_1^2 \delta^2 \\ \alpha_1 \varepsilon - D_1 D_1' \delta^2 \\ \gamma_1 \varepsilon + D_1'^2 \delta^2 \\ D_1 \delta^2 \\ D_1' \delta^2 \\ \delta^2 \end{pmatrix}, \mathcal{N} = \begin{pmatrix} 1 & 0 & 0 & 0 & 0 & 0 \\ C_2^2 & -2C_2 S_2 & S_2^2 & 2C_2 \xi_2 & 2S_2 \xi_2 & \xi_2 \\ C_3^2 & -2C_3 S_3 & S_3^2 & 2C_3 \xi_3 & 2S_3 \xi_3 & \xi_3 \\ C_4^2 & -2C_4 S_4 & S_4^2 & 2C_4 \xi_4 & 2S_4 \xi_4 & \xi_4 \\ C_5^2 & -2C_5 S_5 & S_5^2 & 2C_5 \xi_5 & 2S_5 \xi_5 & \xi_5 \\ C_6^2 & -2C_6 S_6 & S_6^2 & 2C_6 \xi_6 & 2S_6 \xi_6 & \xi_6 \end{pmatrix}$$

• Invert N, multiply with  $\Sigma$  to get  $\Sigma'$ 

$$\begin{array}{l}
\mathcal{O}^{2} = S\xi \\
D_{1} = S\xi S\xi \\
D_{1}^{C} = S\xi S\xi \\
\mathcal{O}_{1}^{C} = S\xi S\xi \\
\mathcal{O}_{1} = A / \sqrt{AC - B^{2}} \\
\mathcal{O}_{1} = B / \sqrt{AC - B^{2}} \\
\mathcal{O}_{2} = \sqrt{AC - B^{2}}
\end{array}$$

$$\begin{array}{l}
\mathcal{A} = S\xi - S\xi^{2}S\xi \\
\mathcal{B} = S\xi + S\xi S\xi^{C} \\
\mathcal{C} = S\xi - S\xi^{2}S\xi^{C} \\
\mathcal{C} = S\xi - S\xi^{2}S\xi^{C} \\
\mathcal{C} = S\xi^{2}S\xi^{C} \\
\mathcal{C}$$

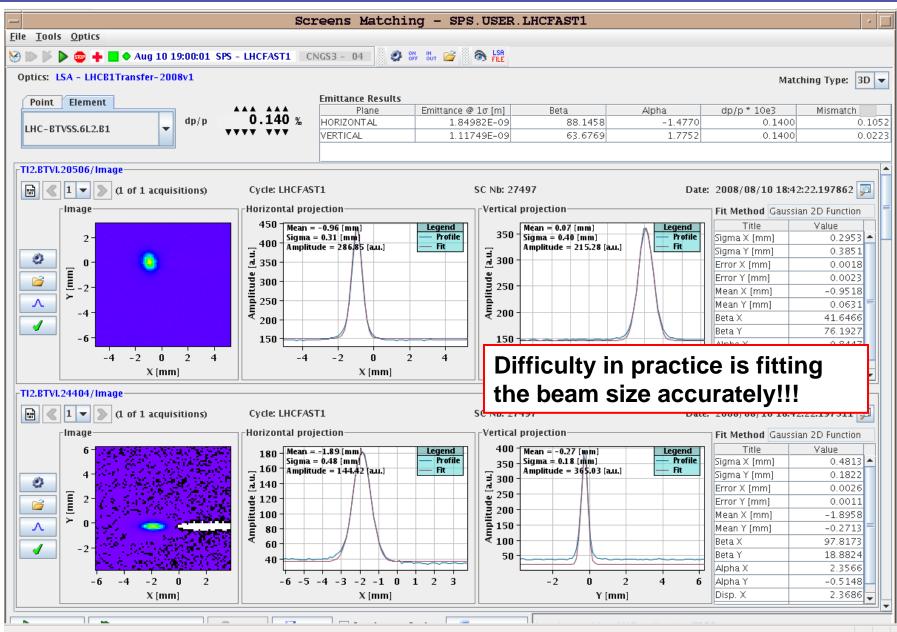
### More than 6 screens...

- Fit procedure...
- Function to be minimized:  $\Delta_i$ ...measurement error

$$\chi^{2}(\Pi) = \sum_{i=1}^{N_{mon}} \left[ \frac{\Sigma_{i} - (\mathcal{M}_{\Pi})_{i}}{\Delta_{i}} \right]^{2} \qquad \qquad \frac{\P C^{2}}{\P P_{i}} = 0 \quad (*)$$

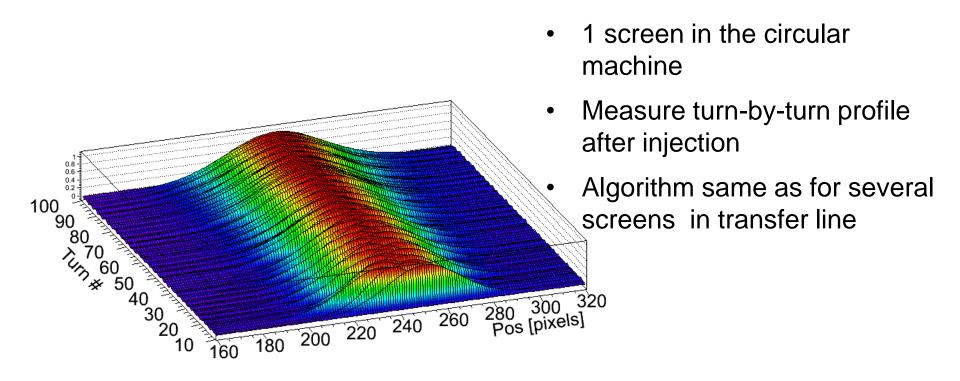
- Equation (\*) can be solved analytically see
  - G. Arduini et al., "New methods to derive the optical and beam parameters in transport channels", Nucl. Instrum. Methods Phys. Res., 2001.

#### In Practice....



ne

# Matching screen

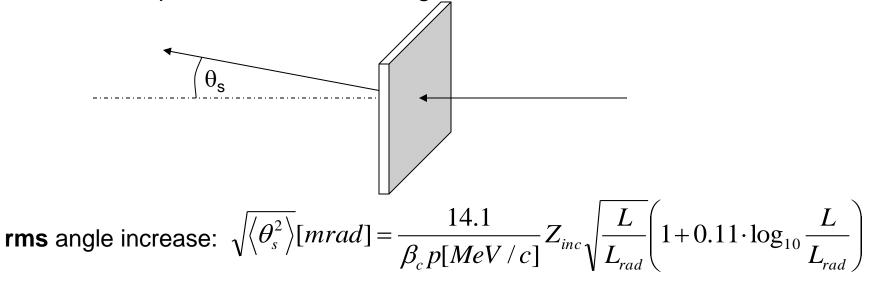


Profiles at matching monitor after injection with steering error.

- Only allowed with low intensity beam
- Issue: radiation hard fast cameras

#### Blow-up from thin scatterer

- Scattering elements are sometimes required in the beam
  - Thin beam screens  $(Al_2O_3,Ti)$  used to generate profiles.
  - Metal windows also used to separate vacuum of transfer lines from vacuum in circular machines.
  - Foils are used to strip electrons to change charge state
- The emittance of the beam increases when it passes through, due to multiple Coulomb scattering.



 $\beta_c = v/c$ , p = momentum,  $Z_{inc} = particle charge /e$ , L = target length,  $L_{rad} = radiation length$ 

#### Blow-up from thin scatterer

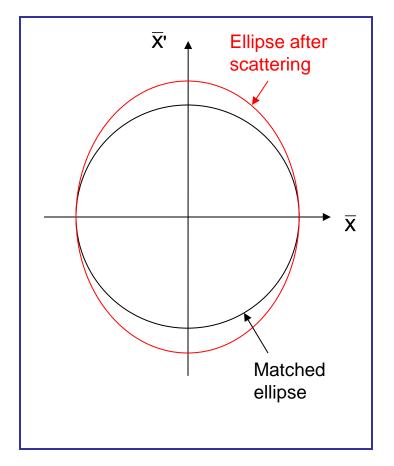
Each particles gets a random angle change  $\theta_{\rm s}$  but there is no effect on the positions at the scatterer

$$\overline{\mathbf{X}}_{new} = \overline{\mathbf{X}}_{\mathbf{0}}$$

$$\overline{\mathbf{X}}'_{new} = \overline{\mathbf{X}}'_{\mathbf{0}} + \sqrt{\beta}\theta_s$$

After filamentation the particles have different amplitudes and the beam has a larger emittance

$$\varepsilon = \left\langle A_{new}^2 \right\rangle / 2$$



#### Blow-up from thin scatterer

$$A_{new}^{2} = \overline{\mathbf{X}}_{new}^{2} + \overline{\mathbf{X}}_{new}^{'2}$$

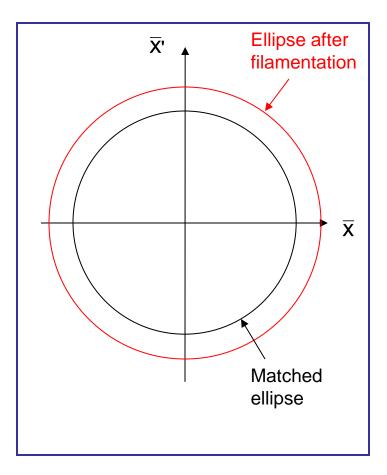
$$= \overline{\mathbf{X}}_{0}^{2} + (\overline{\mathbf{X}}_{0}' + \sqrt{\beta}\theta_{s})^{2}$$

$$= \overline{\mathbf{X}}_{0}^{2} + \overline{\mathbf{X}}_{0}^{'2} + 2\sqrt{\beta}(\overline{\mathbf{X}}_{0}'\theta_{s}) + \beta\theta_{s}^{2} \qquad \text{uncorrelated}$$

$$\langle \mathbf{A}_{new}^{2} \rangle = \langle \overline{\mathbf{X}}_{0}^{2} \rangle + \langle \overline{\mathbf{X}}_{0}^{'2} \rangle + 2\sqrt{\beta} \langle \overline{\mathbf{X}}_{0}'\theta_{s} \rangle + \beta \langle \theta_{s}^{2} \rangle$$

$$= 2\varepsilon_{0} + 2\sqrt{\beta} \langle \overline{\mathbf{X}}_{0}' \rangle \langle \theta_{s} \rangle + \beta \langle \theta_{s}^{2} \rangle$$

$$= 2\varepsilon_{0} + \beta \langle \theta_{s}^{2} \rangle$$

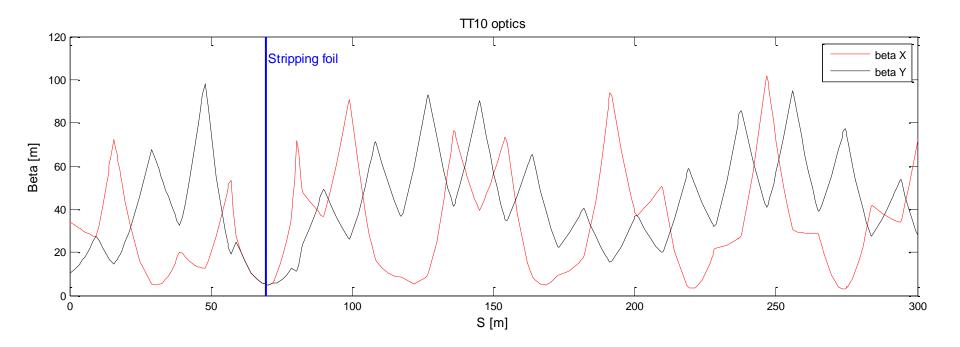


$$\varepsilon_{new} = \varepsilon_0 + \frac{\beta}{2} \left\langle \theta_s^2 \right\rangle$$

<u>Need to keep  $\beta$  small to minimise blow-up</u> (small  $\beta$  means large spread in angles in beam distribution, so additional angle has small effect on distn.)

### Blow-up from charge stripping foil

- For LHC heavy ions, Pb<sup>53+</sup> is stripped to Pb<sup>82+</sup> at 4.25GeV/u using a 0.8mm thick AI foil, in the PS to SPS line
- $\Delta\epsilon$  is minimised with low- $\beta$  insertion ( $\beta_{xy} \sim 5$  m) in the transfer line
- Emittance increase expected is about 8%



## Kick-response measurement

• The observable during kick-response measurement are the elements of the response matrix R

$$R_{ij} = \frac{u_i}{O'_j} \qquad R_{ij}^{\text{mod}el} = \begin{cases} \sqrt{b_i b_j} \sin(m_i - m_j) & \text{for } \mu_i > \mu_j \\ 0 & \text{otherwise} \end{cases}$$

- u<sub>i</sub> is the position at the i<sup>th</sup> monitor

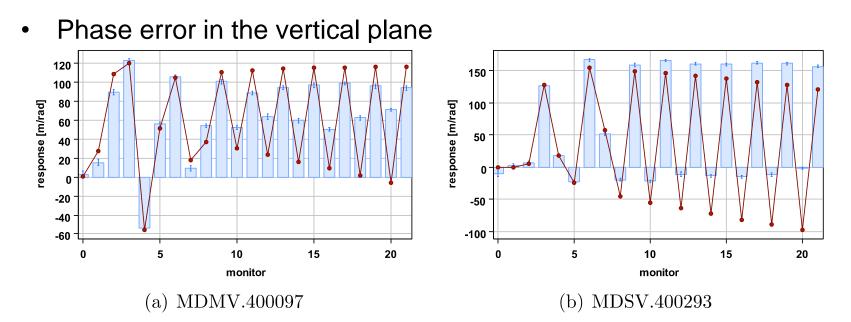
 $\Box$   $\delta_i$  is the kick of the j<sup>th</sup> corrector

- Cannot read off optics parameters directly
- A fit varies certain parameters of a machine model to reproduce the measured data → LOCO principle
- The fit minimizes the quadratic norm of a difference vector V

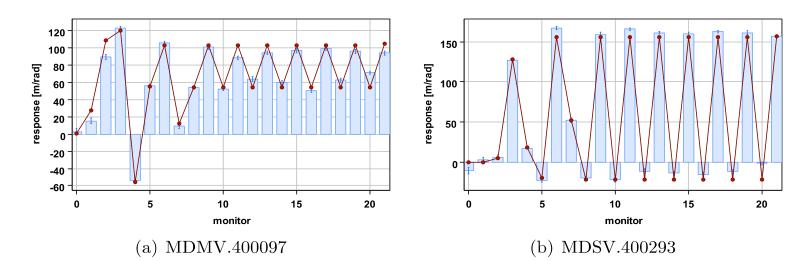
 $V_{k} = \frac{R_{ij}^{meas} - R_{ij}^{mod \, el}}{S_{i}} \qquad k = i \times (N_{c} - 1) + j \qquad \begin{array}{c} \sigma_{i} \dots \text{ BPM rms noise} \\ \mathsf{N}_{c} \dots \text{ number of correctors} \end{array}$ 

Reference: K. Fuchsberger, CERN-THESIS-2011-075

# Example: LHC transfer line TI 8



• Traced back to error in QD strength in transfer line arc:



# Summary

- Transfer lines present interesting challenges and differences from circular machines
  - No periodic condition mean optics is defined by transfer line element strengths <u>and by initial beam ellipse</u>
  - Matching at the extremes is subject to many constraints
  - Emittance blow-up is an important consideration, and arises from several sources
  - The optics of transfer line has to be well understood
  - Several ways of assessing optics parameters in the transfer line have been shown

# Keywords for related topics

- Transfer lines
  - Achromat bends
  - Algorithms for optics matching
  - The effect of alignment and gradient errors on the trajectory and optics
  - Trajectory correction algorithms
  - SVD trajectory analysis
  - Phase-plane exchange insertion solutions